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June 28, 2001



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650 • 849 • 6600

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ATTORNEY DOCKET NO.: 03180.0282
CUSTOMER NUMBER: 22,852

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

New U.S. Patent Application

Title: PLASMA PROCESSING APPARATUS WITH REDUCED PARASITIC
CAPACITY AND LOSS IN RF POWER

Inventors and Addresses:

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Sir:

We enclose the following papers for filing in the United States Patent and
Trademark Office in connection with the above patent application.

1. Application - 22 pages, including 5 independent claims and 28 claims total.
2. Drawings - 9 sheets of formal drawings containing 12 figures.
3. Certified copy of Japanese Patent Application No. 2000-195165 Application No., filed June 28, 2000.

4. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with document attached.
5. The filing fee is calculated as follows:

Basic Application Filing Fee					\$710	\$ 710.00
	Number of Claims		Basic	Extra Claims		
Total Claims	28	-	20	8	x \$18	144.00
Independent Claims	5	-	3	2	x \$80	160.00
[] Presentation of Multiple Dep. Claim(s)					+\$270	
					Subtotal	\$ 1014.00
					Reduction by 1/2 if small entity	-
					TOTAL APPLICATION FILING FEE	\$ 1014.00

6. A check for \$1014.00 is enclosed. The fee includes
\$710 filing fee; and
\$304 additional claims fee

This application is being filed under the provisions of 37 C.F.R. § 1.53(f). Applicants await notification from the Patent and Trademark Office of the time set for filing the Declaration.

Applicants claim the right to priority based on Japanese Patent Application No. 2000-195165 Application No., filed June 28, 2000.

Please address all correspondence with respect to this application to:

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Please accord this application a serial number and filing date.

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Assistant Commissioner of Patents

June 28, 2001

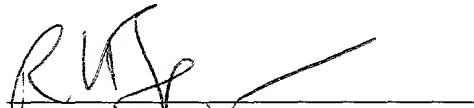
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The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By:


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RVB/FPD/dvz

Enclosures